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CONFIRMATION NO. 8846

SERIAL NUMBER 10/750,251	FILING DATE 12/31/2003  RULE	CLASS 438	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 20059/PIA31199	
APPLICANTS  Young Hun Seo, Seoul, KOREA, REPUBLIC OF;  ** CONTINUING DATA ***** <p style="text-align: center;">None. EP</p> ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2003-0007000 02/04/2003 <i>verified. EP</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/03/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>EP</i>		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS  DRAWING 5	TOTAL  CLAIMS 53	INDEPENDENT  CLAIMS 21
ADDRESS 34431 HANLEY, FLIGHT & ZIMMERMAN, LLC 20 N. WACKER DRIVE SUITE 4220 CHICAGO, IL 60606					
TITLE Methods of fabricating silicon on insulator substrates for use in semiconductor devices					
FILING FEE  RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )		

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